



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

DON E. CURRY, ET AL.

Application No.: 09/828,067

Filed: April 6, 2001

For:

A WAFER PROCESSING APPARATUS HAVING A

CHAMBER WITH AN UPPER WALL HAVING GAS SUPPLY OPENINGS FORMED THEREIN WHICH PROMOTE MORE

EVEN PROCESSING OF A WAFER

Art Group: 1763

Examiner: Rudy Zervigon

A CHILL

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month extension of time, extending the period for response to May 06, 2003, from the Office Action dated January 06, 2003. The petition filing fee of \$110.00 and a Amendment and Response to Office Action are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

05/09/2003 HTECKLU1 00000089 09828067

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110.00 OP

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

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CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Commissioner for Patents, P.O.

Box 1450, Alexandria, VA 22313-1450 on: May 05,

Yebra L. Riggio

Date